

Patent  
10007744-1

**RESPONSE UNDER 37 CFR SECTION 1.116  
EXPEDITED PROCEDURE - GROUP ART UNIT 1765**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

Simon Dodd

Application No.: 09/932,055

Filed: August 16, 2001

For: THERMAL INKJET PRINthead  
PROCESSING WITH SILICON  
ETCHING

Examiner: Lynette T. Umez-Eronini

Group Art Unit: 1765

Confirmation No.: 5019

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**RESPONSE TO THE FINAL OFFICE ACTION**

MAIL STOP AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the final Office Action of January 11, 2006, please amend the above-identified application for patent as follows.

*Enter Amendment,  
L.T.M-E,  
3/23/2006*

**BEST AVAILABLE COPY**